

UED Opportunities for Dynamical Imaging of Materials

Contribution ID: 30

Type: **not specified**

TD02 - "Current status of MeV-UED/UEM and electron imaging optics development at BNL" Xi Yang, BNL

Tuesday, 7 November 2023 16:20 (20 minutes)

Session Classification: Session TD - Chair: Kip Bishofberger